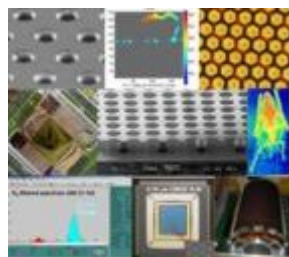


Session Program

16-18 Apr 2008



Micro-Pattern Gas Detectors (RD51) Workshop

MPGD applications II

NIKHEF, Amsterdam

Friday 18 April

11:20

MPGD applications II

Session | Location: NIKHEF, Amsterdam | Convener: Paul Colas

11:20-11:40 Thin layer Amorphous Silicon technology

Speaker
Nicolas Wyrsh

11:40-12:00 TPC prototype for ILC

Speaker
Klaus Dehmelt

12:00-12:20 R&D of gating GEM

Speaker
Akira Sugiyama

12:20-12:40 Resistive anode readout

Speaker
Stephen Turnbull

12:40-13:00
Scintillation readout from micropatterned electron multipliers for dual-phase dark matter detectors

Speaker
Joaquim dos Santos

13:00